



AF/2675

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Norihiro Imai, et al.

Serial No.: 10/062,279

Filed: January 30, 2002

For: BACK LIGHT CONTROL
METHOD AND DISPLAY
DEVICE

Group Art Unit: 2675

Examiner: U.O. Anyaso

Attorney Docket: OMRN P015

CERTIFICATE OF MAILING

Date of Deposit: September 28, 2004

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INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §1.56 AND §§1.97-1.98

Commissioner for Patents
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Sir:

The following Form 1449 and copies of documents listed thereon are being filed herewith as a Disclosure Statement. Consideration of each of these documents by the Patent Examiner, and the making of each of them of record in the file of this application, are respectfully requested.

Each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

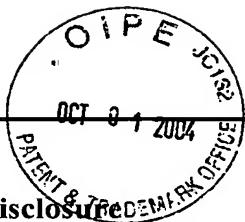
Respectfully submitted,



Keiichi Nishimura
Registration No. 29,093

September 28, 2004
BEYER WEAVER & THOMAS, LLP
P.O. Box 778
Berkeley, CA 94704-0778
Telephone: (510) 843-6200
Telefax: (510) 843-6203

Form 1449 (Modified)



Information Disclosure Statement By Applicant

(Use Several Sheets if Necessary)

Atty Docket No.

OMRNP015

Applicant:

Norihiro Imai, et al.

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Application No.:

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Group

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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A						
	B						
	C						
	D						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	E	11-126118	11/05/99	Japan			X	
	F	03-168616	22/07/91	Japan			X	
	G	2000-276248	06/10/00	Japan			X	
	H	05-224713	03/09/93	Japan			X	
	I	05-289707	05/11/93	Japan			X	
	J	06-075610	18/03/94	Japan			X	
	K	2000-242315	08/09/00	Japan			X	

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	L	
	M	
	N	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.